



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2811
Examiner: Junghwa M, IM

In Re PATENT APPLICATION Of:

Applicant(s): Kazutaka SHIBATA

Serial No.: 10/608,016

Filed: June 30, 2003

For: SEMICONDUCTOR DEVICE AND
MANUFACTURING METHOD THEREOF

Attorney Ref.: AI 288

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) **INFORMATION DISCLOSURE
STATEMENT WITH
CERTIFICATION**
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)

May 31, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is an information disclosure statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97(e)(2) after a Final Rejection, but before a Notice of Allowance. The reference submitted with this Information Disclosure Statement was first cited in an Office Action from the U.S. Patent Office in a related U.S. patent application (Ser. No. 10/901,077) on May 15, 2006.

The documents are listed on the attached Form PTO-1449. A check in payment of the fee under 37 C.F.R. §1.17(p) is also enclosed. If the check is missing, or made out for an insufficient amount, please charge our deposit account, No. 18-0002, for any deficiency and notify us accordingly.

Consideration of the submitted documents is respectfully requested.

Respectfully submitted,

May 31, 2006
Date

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FORM PTO-1449

INFORMATION DISCLOSURE STATEMENT

Atty. Docket:
AI 288Application No.:
10/608,016Applicant:
Kazutaka SHIBATAFiling Date:
June 30, 2003Group Art Unit:
2811

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
-	AA	US-6,476,503	11/2002	Imamura et al.	257/780	-	-
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub-Class	Translation
	AI						
	AJ						
	AK						
	AL						
	AM						

OTHER (Including Author, Title, Date, Pertinent Pages, etc.)

	AN	
	AO	

Examiner

Date Considered

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.